OSAKA VACUUM, LTD.

GULDE FOR GAS-PURGING TO BE APPLIED TO MOLECULAR PUMPS

Applicable to: TH162/163

TH522

TH1502/1503
TG200/203/2X3
TG550/553/551B
TG1000/1003/1005
TG1810/1813/1815
TG360M/363M
TG600M/603M
TG2200M/2203M
TG1300/1303

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1. Function of Gas-Purging Mechanism and its Basic Construction
In evacuating corrosive gases or gases containing much dust
by a molecular pump, if such gases intrude in the motor housing
where there are incorporated a driving device consisting of a
motor and bearings, etc., there may be created the cause of
mishap to the bearings, etc. The gas-purging mechanism
has the construction not to admit external gases to be pumped
out by sealing the housing excepting the narrow interspace
between the housing and the rotor, through which clean gas
flows out. Our original spiral sealing applied to the
interspace above-mentioned heightens the sealing effect more
successfully. The sectional view of the mechanism is as
shown in Fig.1 (The accompanying dwg."R4-06099).

2. Piping Arrangement

An example of piping arrangement from the purging gas source to the molecular pump is shown in the flow diagram in Fig.2. Each of the devices required for the piping is available on request (Optional).

2.1 Purging gas inlet

The sectional view of the purging gas inlet of the molecular pump is shown in Fig.3

2.2 Safety valve

The valve is for protecting the pressure inside the molecular pump from being heightened. Its set pressure is $0.7~{\rm kg/cm^2G}$.

2.3 Purging-gas vacuum valve

This valve is the manually- or solenoid-operated vacuum valve.

2. Piping Arragement - Continued

2.4 Flow-regulating valve

Two kinds of flow controlling devices are available on request, i.e. a flow-regulating valve provided with a flowmeter (whose primary-side pressure is $0.5 \text{kg/cm}^2\text{G}$) practicable for visual validation of flowrate, and a flow controller (whose primary-side pressure is $0.4 \sim 0.8 \text{ kg/cm}^2\text{G}$) practicable for retaining the set flowrate constantly, irrespective of the fluctuation of the primary-side pressure.

2.5 <u>Pressure-reducing valve</u>

The pressure of gases supplied from the purging gas source is reduced to the set primary pressure of the flow-regulating valve by this pressure-reducing valve.

2.6 Leak Valve

This valve is for the displacement of the gases to be evacuated out of the molecular pump after its shut-down with purging gas.

3. Kinds of Purging Gas

Generally such gases as dried air, $\ensuremath{\text{N}}_2$ or Ar are suitable for the purpose.

4. Flowrate of Purging Gas

Standard flowrate of purging gas for each model of molecular pump is shown as below:

| MODEL OF MOLECULAR PUMP | FLOWRATE OF (SCCM) PURGING GAS |
|----------------------------------|--------------------------------|
| T H 162/163 | 2 |
| T H 5 2 2 | 5 |
| T H 1502/1503 | 1 0 |
| T G 200/203/2X3 | 5 |
| T G 550/553/551B | 2 0 |
| TG1000/1003/1005 | 2 0 |
| TG1810/1813/1815 | 2 0 |
| T G 360M/363M | 5 |
| T G 600M/603M | 2 0 |
| T G 2200M/2203M T G 1300/1303 | 2 0 2 0 |

5. <u>Start-up/Shut-down Procedure for Gas-Purging Type Molecular Pump</u>

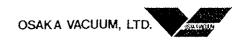
In pumping-out the harmful gases with the gas-purging type molecular pump, it is necessary to operate the pump not to admit those gases into its motor housing.

The standard steps of procedure are as shown below:

5.1 Start-Up

- 1) Close the leak valve, open the purge gas vacuum valve.
- 2) Open the purging-gas main valve to introduce purging gas into the pump.
- 3) Open the forevacuum valve.
- 4) Start up the backing pump to evacuate the molecular pump.
- 5) Open the main valve.
- 6) Turn-on the molecular pump power supply.

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5.2 Shut-Down

- 1) Close the main valve.
- 2) Turn-off the power supply, open the leak valve.
- 3) In several minutes, close the forevacuum valve.
- 4) Shut down the backing pump, close the leak valve.
- 5) In several minutes, close the purging gas vacuum valve, and the vacuum of several Torr will be self-held within the pump.
- 6) Close the purging gas main valve.

6. <u>Simplified System</u>

6.1 Forevacuum Valve

When the backing pump has a built-in backstream preventing valve, the forevacuum valve can be omitted, and the steps 5-1-(3) and 5-2-(4) are dispensed with.

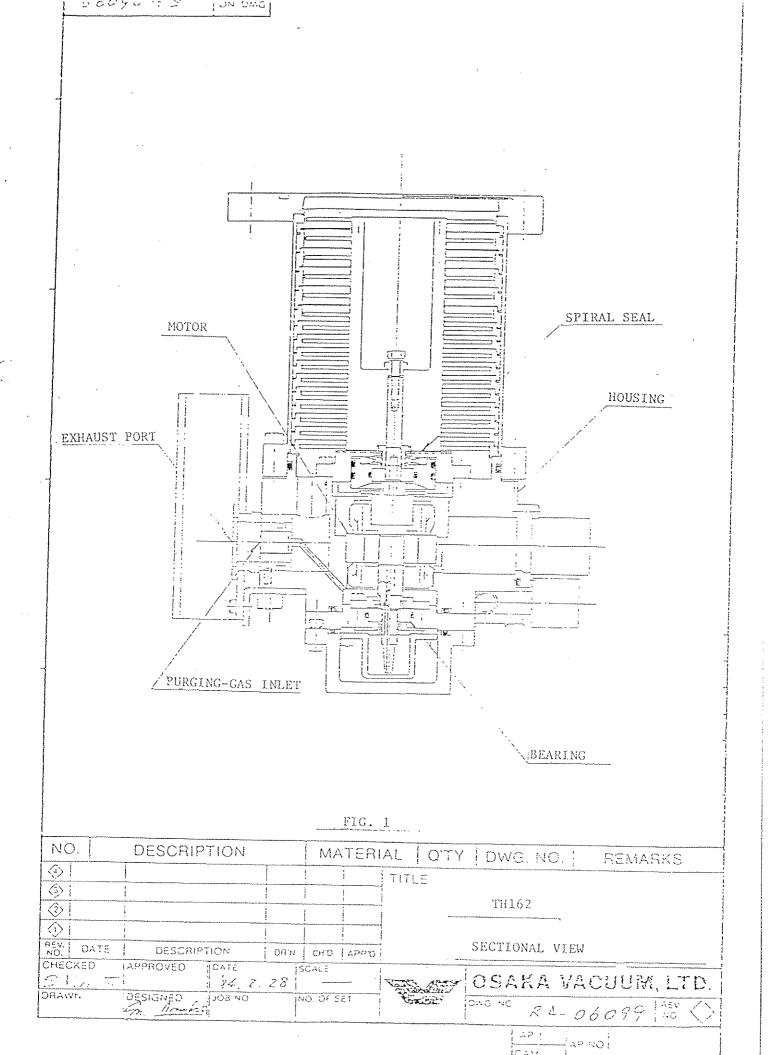
6.2 <u>Safety Valve</u>

When the pressure on the secondary-side regulated by the pressure-reducing valve is under $0.7~{\rm kg/cm^2G}$, the safety valve can be omitted.

7. In Case of Power Failure during Unattended Operation

Keep up supplying purging gas.

It is advisable to let the main valve to automatically close.



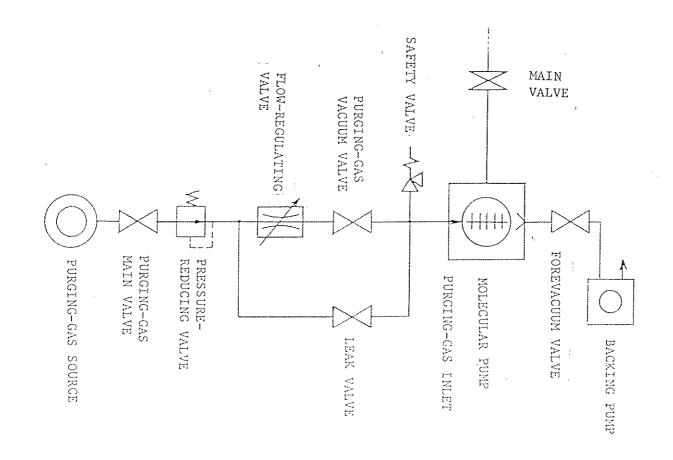


FIG. 2

| NO. | | DESCRIF | MATERI | | IAL Q'TY | | DWG. NO. | REMARKS | | | | | |
|--------------|------|----------|----------------|-----|----------|------|----------|-----------|--------------|-----------------|--|--|--|
| (A) | | | | | | - | TITE | £= | | | | | |
| <u> </u> | | | | | | | | FLOW | CHART OF PUR | GING-GAS PIPING | | | |
| REV. | DATE | DESCRIF | PTION | DRW | СН.О | GRAA | | | | | | | |
| CHEC 乡 :: | KED | APPROVED | DATE 198410 | | SCALE | | V | ASST | OSAKA V | ACUUM, LTD. | | | |
| DRAV | /N | DESIGNED | JOS NO 2 | | NO. OF S | SE 1 | | escului . | DWG NO 4- | REV. NO | | | |
| | | | | | | | ** | | AP | AP NO. | | | |

CAM

ON SAIG

PURGING-GAS INLET JUNCTION

PF i/4" SCREW

* This face is machine-finished suitable for O-ring seal.

FIG. 3

| DRAWN | | DESIGNED | 1708 NO | THE COMMERCE VALUE | VO OF S | ÉT | | | OWG NO | 4 - | REV \ |
|----------------|------|--------------|---------|--------------------|--------------|----------|------------------|------|--------|---------|------------|
| S. C. | | APPROVED | 84.3. | | SCALE /] | / | | | OSA | (A VA | CUUM, LTD. |
| REV. I | DATE | DESCRI | | | CH.D | APP'0 | | | | | |
| (1) | | | *** | | - | <u> </u> | | | Q | ECTIONA | i viru |
| <u> </u> | | <u> </u> | | | | ! | Pile promiser to | | PURGIN | IC-GAS | INLET |
| % - | · | 1 | | | 1 | |] [[] | • | | | |
| (A) | | I | | | | | TITI | Ę | | | |
| NO. | | DESCRIPTION | | | MATERI | | AL | Q'TY | DWG. | NO. | REMARKS |

CAM AP NO

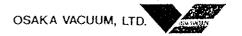
GENERAL TERMS OF WARRANTY

Osaka Vacuum, Ltd. hereby guarantees that all product(s) delivered hereunder are in accordance with the specifications, terms and conditions of the contract and are free from all defects in design, materials, and workmans: ship. The period of warranty is one (1) year from the date of delivery. Should any part or parts of said prodict(s) prove defective during this period, we agree to repair or replace at our option such defective part(s) as we deem necessary to reduce losses to a minimum. The warranty stated above is, however, applicable only if the product is properly used, in accordance with the instruction manual or other instructions furnished by us, and is not applicable to any problems,

- Resulting from misuse, improper operation or negligence in maintenance;
- 2) In products repaired or modified by unauthorized persons;
- 3) Due to fire, flood, earthquake, lightning and/or other natural forces beyond the control.

Our liability shall be limited to alterations, repairs and/or replacement of defective part(s) and shall not include any damage or loss resulting from said defects. Our indemnity, whether based on warranty or otherwise, shall in no case exceed the price of the contracted product(s). Minor deviations from specifications, which do not affect performance of the product(s) covered hereby, shall not be deemed to constitute defects of materials, workmanship and/or failure to comply with the specifications referred to herein.

The foregoing warranty does not apply to rubber goods, bulbs and/or other consumable items. This warranty applies only to products stipulated in the specifications, terms and items of the contract. Nothing herein contained shall extend or be construed to extend the original warranty period of one year.



REQUEST FOR INFORMATION ON YOUR MOLECULAR PUMP TO BE REPAIRED

Please fill out and send this form to us together with your pump.

Date:

| | FIRM | | DEPT. | | | | | | |
|--|----------------------------------|--|---|-------|--|--|--|--|--|
| CLIENT | PHONE | EXTENSION | YOUR NAME | | | | | | |
| MODEL NO. OF PUMP | | | OPERATION TIME CUMULATED | hrs | | | | | |
| The second secon | | | | | | | | | |
| l. Motivat | ion for Repai | r | | | | | | | |
| a. T | rouble a-l | 'Inoperable' a-2 | 'Noisy' a-3 'Leaky' | , | | | | | |
| | a-4 | Others (| |) | | | | | |
| b. P | eriodical Ins | pection : Its number of | times times | | | | | | |
| c. 0 | thers (| | |) | | | | | |
| 2. Your Pu | mp has been u | sed for: | | | | | | | |
| a. <i>D</i> | Ory etching (o | n Aluminum; Polysillico | ne; Oxidized membrane; Othe | ers) | | | | | |
| b. <i>C</i> | <i>TVD</i> c. | MOCVD d. Sputte | ring e. Gas analy | sis | | | | | |
| f. s | urface analys | is g. Others | (|) | | | | | |
| 3. <u>Kinds o</u> | f Intaken Gas | (Please enumerate all) | cinds of gases intaken) | | | | | | |
| 4. <u>Intaken</u> | | Please enumerate all sub Vafer fragments, Reactar | ostance imaginable – e.g. nts, etc.) | | | | | | |
| | | | | | | | | | |
| . <u>Cleansi</u> | ng made on you | ir Pump prior to its ser | iding to us: | | | | | | |
| Rank | 'a' Noth | ing cleansed. | | | | | | | |
| Rank | | casing; Stator blades et port; Outer circumfe | : Distance pleces; SGP st erence of Rotor; | ator; | | | | | |
| | | | is/are cleanse | d. | | | | | |
| Rank | | r circumference of disas r circumference of Motor | ssembled Rotor; Housing is cleansed | | | | | | |
| tl | ntaken by your nat such parts | pump be detrimental to | and 'b', should the gases be health, please remember ght be sent back to you sembled by us. | | | | | | |